

<b>Notice of References Cited</b>	Application/Control No. 10/002,722	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Shuwang Liu	Art Unit 2634	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,842,438	01-2005	Benedict et al.	370/328
	B	US-6,286,122	09-2001	Alanara, Seppo	714/781
	C	US-6,272,186	08-2001	Bontu et al.	375/340
	D	US-5,710,772	01-1998	Sato, Osamu	370/458
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
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	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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